

Notice of References Cited	Application/Control No. 10/671,143		Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Rodney G. McDonald		Art Unit 1753	Page 1 of 1

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*	B	US-RE38,561	08-2004	Keesmann et al.	313/309
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NON-PATENT DOCUMENTS

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	U	Bower et al. "Plasma-induced alignment of carbon nanotubes", Applied Physics Letters, Volume 77, Number 6, August 2000, pp. 830-832.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.